

# Search Notes



Application/Control No.

10/697,644

Examiner

David A. Vanore

Applicant(s)/Patent under Reexamination

GARZA ET AL.

Art Unit

2881

## SEARCHED

Class	Subclass	Date	Examiner
250	491.1 492.2 492.21 492.22 492.23 492.1	3/15-16/05	DEA
430	5		
355	71-72 69 55 53 52 30		

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
<p>CONSULTED JOHN R. LEE RE:</p> <p>CLAIM 7: Objection.</p> <p>112 1<sup>st</sup></p> <p>112 2<sup>nd</sup></p> <p>102 Rej</p> <p>Fast keyword search.</p> <p>INVENTORS SEARCHED ON EQU and EAST.</p> <p>ASSIGNEE search.</p> <p>Internet search on Ion Implants from Axcelis, VARIAN, SEN</p> <p>IEEE search on Ion Gauges</p> <p>Gauge systems search on Axcelis, + GSD</p> <p>+ NV-GSD, etc.</p> <p>w/ ion gauge, cryopump and permutations thereof.</p>		